

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent No.: 6,861,703

Issue Date: March 1, 2005

Inventor: INAGAWA et al.

Appl. No.: 10/657,246

Filed: September 9, 2003

Title: SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING  
THE SAME

Customer No.: 24956

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REQUEST FOR CERTIFICATE OF CORRECTION**  
**PATENT OFFICE MISTAKE (37 CFR §1.322)**

Sir:

Please issue a Certificate of Correction based on the attached Certificate of Correction form. Although a Prior Foreign Application (JP10-371330 filed December 25, 1998) is included on page 2 of the Declaration, the box "Priority Not Claimed" was checked. There is no claim for foreign priority benefits under 35 U.S.C. §119.

Since the Certificate of Correction is necessitated by an error on the part of the U.S. Patent and Trademark Office, no fee is submitted herewith. However, should the Patent Office decide that this Request for Certificate

Correction requires a fee, the Commissioner is hereby authorized to charge  
deposit account no. 50-1417 (referencing Atty. Docket No. H-924-02).

Respectfully submitted,

MATTINGLY, STANGER, MALUR & BRUNDIDGE, P.C.

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